

Supplementary Information

**One-pot hydrothermal synthesis of orientated delafossite CuFeO_2 films
from a mildly acidic solution on substrates**

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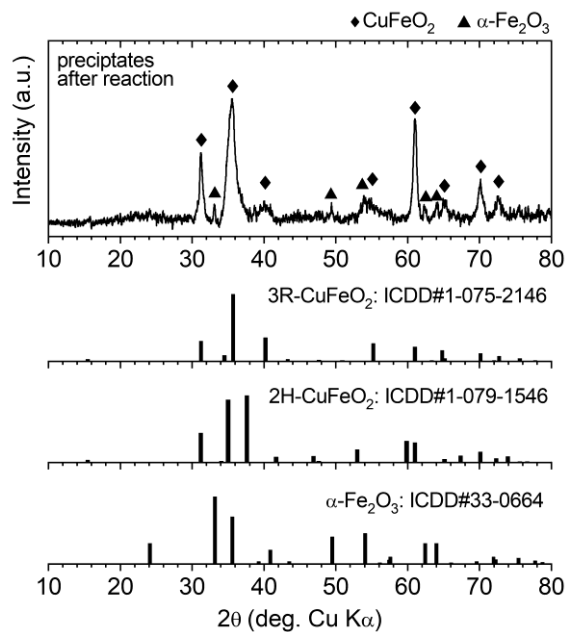


Figure S1. XRD pattern of black powder precipitated in a PTFE vessel after the hydrothermal reaction in $\text{CuSO}_4\text{-FeSO}_4\text{-urea}$ (aq) at 150°C for 1 h. ICDD (no. 1-075-2146) for 3R- CuFeO_2 , (no. 1-079-1546) for 2H- CuFeO_2 and (no. 33-0664) for $\alpha\text{-Fe}_2\text{O}_3$ are presented.

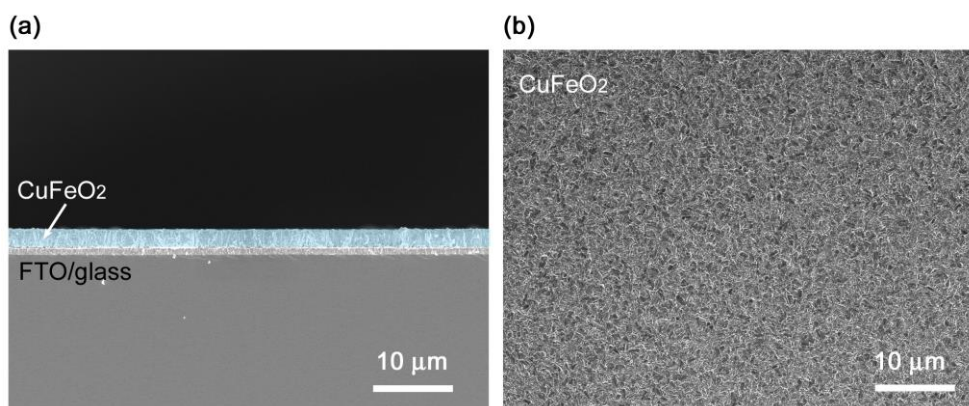


Figure S2. (a) Cross-sectional and (b) top-view FESEM images of the CuFeO_2 film deposited on FTO glass substrates via the hydrothermal reaction in $\text{CuSO}_4\text{-FeSO}_4\text{-urea}$ (aq) at 150°C for 1 h.

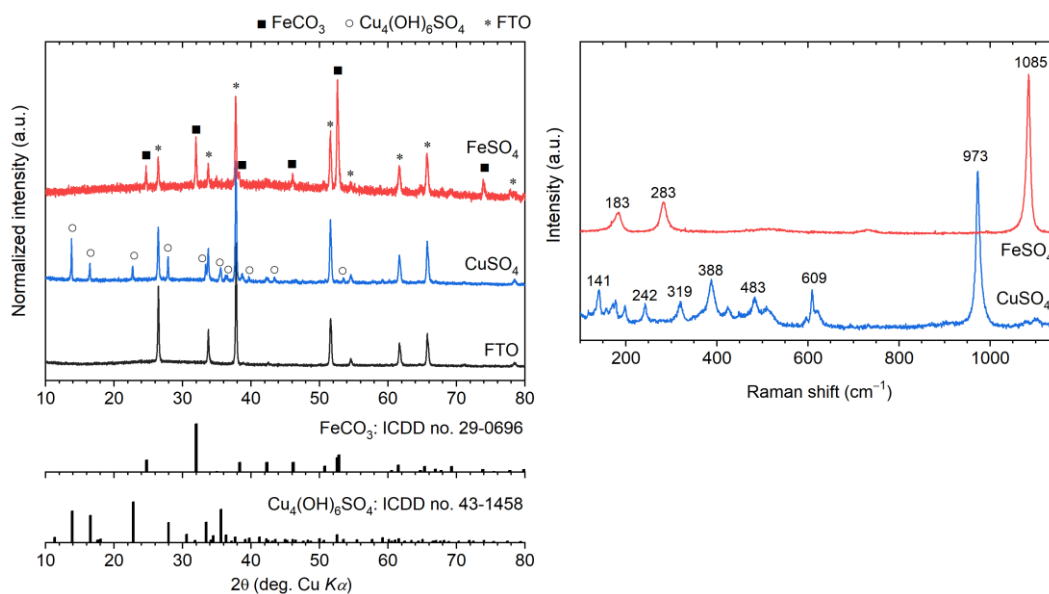


Figure S3. XRD patterns (left) and Raman spectra (right) of the films deposited on FTO glass substrates via the hydrothermal reaction in each CuSO_4 -urea and FeSO_4 -urea (aq) at 150°C for 1 h. ICDD (no. 29-0696) for FeCO_3 and (no. 43-1458) for $\text{Cu}_4(\text{OH})_6\text{SO}_4$ are presented.

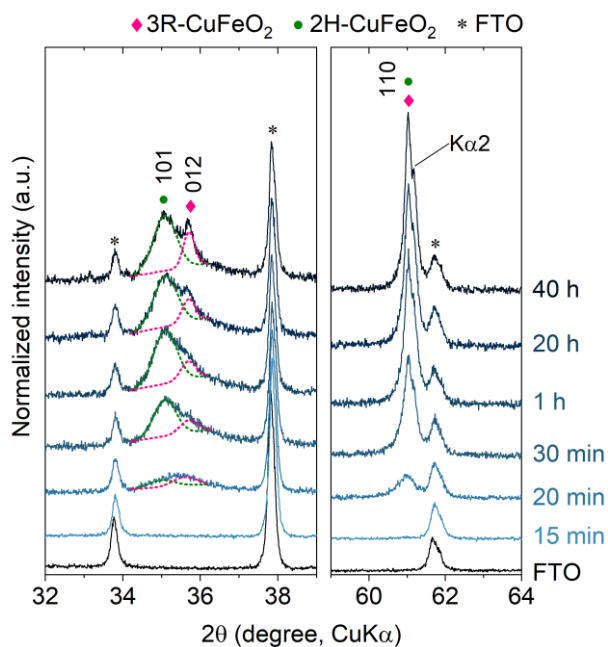


Figure S4. XRD patterns of the films deposited on FTO glass substrates via the hydrothermal reaction in CuSO_4 - FeSO_4 -urea (aq) at 150°C at different reaction times (15 min–40 h).

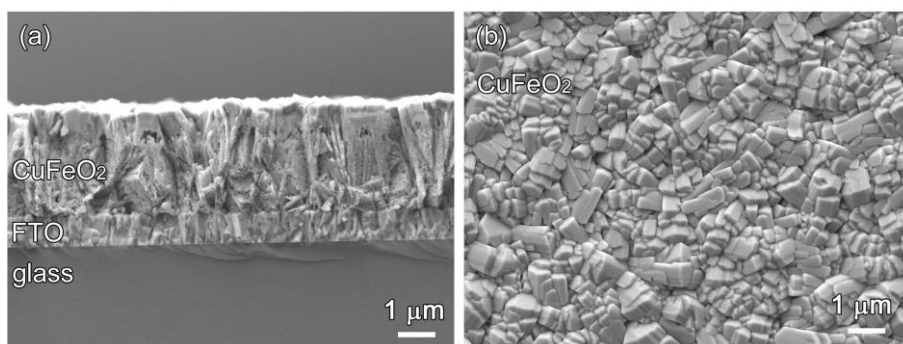


Figure S5. (a) cross-sectional and (b) top-view FESEM images of the CuFeO_2 film deposited on FTO glass substrates via the hydrothermal reaction in $\text{CuSO}_4\text{-FeSO}_4\text{-urea}$ (aq) at 140°C for 1 h.

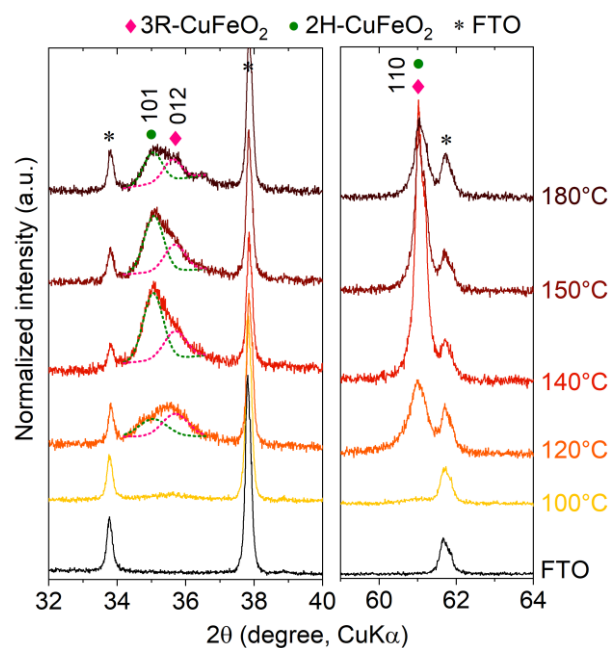


Figure S6. XRD patterns of the films deposited on FTO glass substrates via the hydrothermal reaction in $\text{CuSO}_4\text{-FeSO}_4\text{-urea}$ (aq) for 1 h at different reaction temperatures (100°C – 180°C).

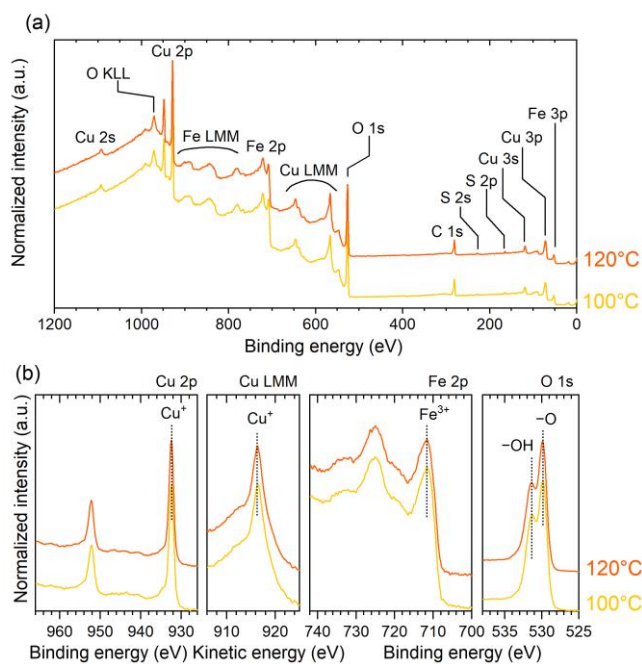


Figure S7. (a) wide-scan and (b) fine-scan XPS spectra of the films deposited on FTO glass substrates via the hydrothermal reaction in $\text{CuSO}_4\text{-FeSO}_4\text{-urea (aq)}$ at 100°C – 120°C for 1 h.

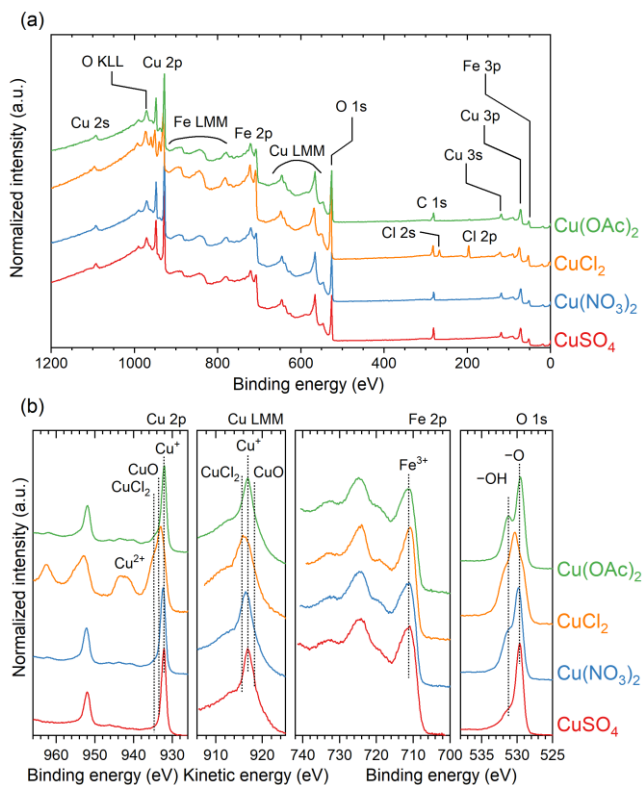


Figure S8. (a) wide-scan and (b) fine-scan XPS spectra of films deposited on FTO glass substrates by the hydrothermal reaction in each copper salt (CuSO_4 , $\text{Cu(NO}_3)_2$, CuCl_2 and Cu(OAc)_2)– $\text{FeSO}_4\text{-urea (aq)}$ at 180°C for 1 h.

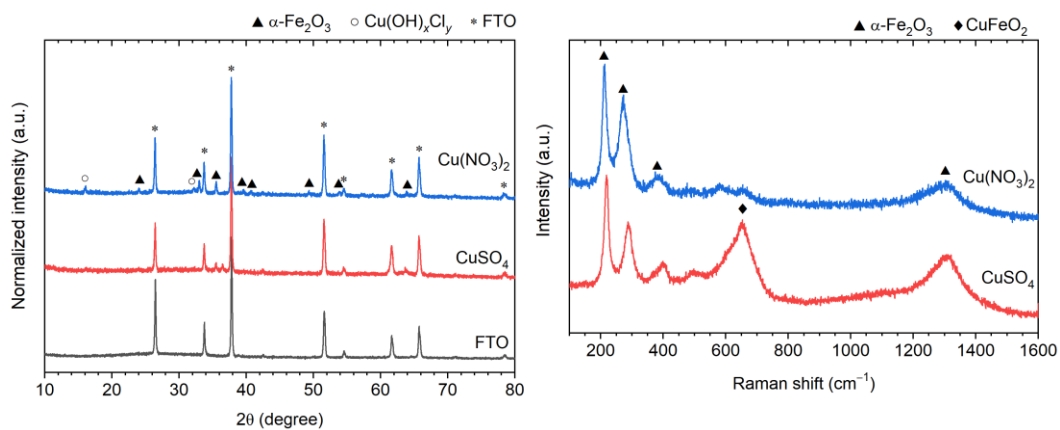


Figure S9. XRD patterns (left) and Raman spectra (right) of the films deposited on FTO glass substrates by the hydrothermal reaction in each copper salt (CuSO_4 and $\text{Cu}(\text{NO}_3)_2$)– FeCl_2 –urea (aq) at 180°C for 1 h.